





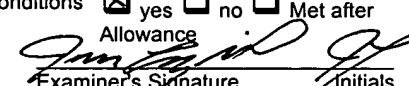

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APPLICANTS Nobuyuki Eto, Tokyo, JAPAN; Hideki Isono, Amphur Muang, THAILAND; 				
** CONTINUING DATA ***** ** FOREIGN APPLICATIONS ***** JAPAN 43212/2003 02/20/2003 				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 05/07/2004				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged  Examiner's Signature  Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 0	TOTAL CLAIMS 6
			INDEPENDENT CLAIMS 1	
ADDRESS 23373				
TITLE Method of processing a glass substrate for a magnetic disk and method of manufacturing the glass substrate				
FILING FEE RECEIVED 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	